

Rce/ITM
PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tetsuya OTSUKI

Group Art Unit: 2818

Application No.: 10/624,680

Examiner: L. TRAN

Filed: July 23, 2003

Docket No.: 116568

For: INTERCONNECT SUBSTRATE,
SEMICONDUCTOR DEVICE, METHODS OF
MANUFACTURING THE SAME, CIRCUIT
BOARD, AND ELECTRONIC EQUIPMENT

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

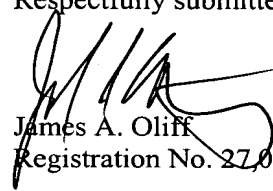
In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the Amendment filed November 4, 2005.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 172601 in the amount of ☒ \$790.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Joel S. Armstrong
Registration No. 36,430

Leana Levin
Registration No. 51,939

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JAO:LL/tlp

Date: November 4, 2005

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